



Welcome United States Patent and Trademark Office

Search Results

[BROWSE](#)[SEARCH](#)[IEEE XPLORE GUIDE](#)[SUPPORT](#)

Results for "((particle filter and mems)<in>metadata)"

Your search matched 3 of 1243738 documents.

A maximum of 100 results are displayed, 25 to a page, sorted by **Relevance** in **Descending** order.

e-mail printer friendly

» Search Options

[View Session History](#)[New Search](#)

Modify Search

((particle filter and mems)<in>metadata)


☐ Check to search only within this results set

 Display Format: ☒ Citation ☐ Citation & Abstract

» Key

IEEE JNL IEEE Journal or Magazine

IEE JNL IEE Journal or Magazine

IEEE CNF IEEE Conference Proceeding

IEE CNF IEE Conference Proceeding

IEEE STD IEEE Standard

Select Article Information

- ☐ 1. **Polymer-based electrospray chips for mass spectrometry**
 Xuan-Qi Wang; Desai, A.; Yu-Chong Tai; Licklider, L.; Lee, T.D.;
 Micro Electro Mechanical Systems, 1999. MEMS '99. Twelfth IEEE International Conference on
 17-21 Jan. 1999 Page(s):523 - 528
 Digital Object Identifier 10.1109/MEMSYS.1999.746883
[AbstractPlus](#) | Full Text: [PDF](#)(788 KB) IEEE CNF
- ☐ 2. **A MEMS electrospray nozzle for mass spectroscopy**
 Desai, A.; Yu-Chong Tai; Davis, M.T.; Lee, T.D.;
 Solid State Sensors and Actuators, 1997. TRANSDUCERS '97 Chicago., 1997 International
 Conference on
 Volume 2, 16-19 June 1997 Page(s):927 - 930 vol.2
 Digital Object Identifier 10.1109/SENSOR.1997.635254
[AbstractPlus](#) | Full Text: [PDF](#)(600 KB) IEEE CNF
- ☐ 3. **Micromachined membrane particle filters**
 Yang, X.; Yang, J.M.; Wang, X.Q.; Meng, E.; Tai, Y.C.; Ho, C.M.;
 Micro Electro Mechanical Systems, 1998. MEMS 98. Proceedings., The Eleventh Annual
 International Workshop on
 25-29 Jan. 1998 Page(s):137 - 142
 Digital Object Identifier 10.1109/MEMSYS.1998.659743
[AbstractPlus](#) | Full Text: [PDF](#)(580 KB) IEEE CNF


 Indexed by
 Inspec

[Help](#) [Contact Us](#) [Privacy & Security](#) [IEEE.org](#)

© Copyright 2005 IEEE - All Rights Reserved